

PATENT Customer No. 22,852 Attorney Docket No. 04788.0247

IN THE UNITED STATES PATENT AND TRADEMARK OFFIC

Group Art Unit: 2851

Examiner: Hung Hguyen

In re Application of:

Yasuhiro OMURA

Application No.: 09/865,734

Filed: May 29, 2001

PROJECTION OPTICAL SYSTEM, For:

> **EXPOSURE APPARATUS** INCORPORATING THIS

PROJECTION OPTICAL SYSTEM. AND MANUFACTURING METHOD FOR MICRO DEVICES USING THE EXPOSURE APPARATUS

Commissioner for Patents Washington, DC 20231

Sir:

PETITION FOR EXTENSION OF TIME

Applicant hereby petitions for a one month extension of time to reply to the Office Action of December 4, 2002. A fee of \$110.00 is enclosed.

Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

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110.00 OP

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,

GARRETT & DUNNER, L.L.P.

Dated: April 4, 2003

Reg. No. 34,629

FINNEGAN HENDERSON FARABOW GARRETT & DUNNER맫

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